

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	78	(US-20010011524-\$ or US-20020011205-\$ or US-20020030443-\$ or US-20020067400-\$ or US-20020076847-\$ or US-20020132047-\$ or US-20030015140-\$ or US-20030101937-\$ or US-20030221620-\$ or US-20040031442-\$ or US-20040216677-\$ or US-20050016462-\$ or US-20050022743-\$ or US-20020056842-\$ or US-20020057055-\$ or US-20020084464-\$ or US-20020104751-\$ or US-20020187265-\$ or US-20030146439-\$ or US-20030153109-\$ or US-20040035360-\$ or US-20040040504-\$ or US-20040061118-\$ or US-20040075112-\$ or US-20040112291-\$ or US-20040113548-\$).did. or (US-20040123804-\$ or US-20040139914-\$ or US-20040168634-\$ or US-20040195965-\$ or US-20040216673-\$ or US-20050005848-\$ or US-20040261709-\$ or US-20010008121-\$ or US-20020139481-\$).did. or (US-3086889-\$ or US-3394678-\$ or US-3554512-\$ or US-3664295-\$ or US-4023523-\$ or US-4401052-\$ or US-4542712-\$ or US-4627989-\$ or US-5242500-\$ or US-5904961-\$ or US-6120834-\$ or US-6179923-\$ or US-6475285-\$ or US-6509061-\$ or US-6514570-\$ or US-6555284-\$ or US-6602382-\$ or US-6649436-\$ or US-6749906-\$ or US-6830626-\$ or US-6837939-\$ or US-6849832-\$ or US-4755364-\$ or US-4856457-\$ or US-4897290-\$ or US-6340501-\$).did. or (US-6551405-\$ or US-3914836-\$ or US-4208042-\$ or US-4312710-\$ or US-6287435-\$ or US-6646284-\$ or US-6664732-\$ or US-6696096-\$ or US-6719886-\$ or US-6797314-\$ or US-6803246-\$ or US-6828727-\$ or US-4948983-\$ or US-5530516-\$ or US-6074893-\$ or US-6258495-\$ or US-6294892-\$).did.	US-PGPUB; USPAT	OR	ON	2005/02/04 17:22
L2	20491	semiconductor.as.	US-PGPUB; USPAT	OR	ON	2005/02/04 17:22
L3	18	semiconductor.as. and 1	US-PGPUB; USPAT	OR	ON	2005/02/04 17:31
L4	2098	yamazaki-shunpei.in. kuwabara-hideaki.in. murakami-masakazu.in.	US-PGPUB; USPAT	OR	ON	2005/02/04 17:32
L5	709	4 and evaporat\$3	US-PGPUB; USPAT	OR	ON	2005/02/04 17:32
L6	655	4 and evaporat\$3 and heat\$3	US-PGPUB; USPAT	OR	ON	2005/02/04 17:33
L7	468	4 and evaporat\$3 and heat\$3 and align\$4	US-PGPUB; USPAT	OR	ON	2005/02/04 17:33
L8	354	4 and evaporat\$3 and heat\$3 and align\$4 and vacuum	US-PGPUB; USPAT	OR	ON	2005/02/04 17:33
L9	72	4 and evaporat\$3 and heat\$3 and align\$4 and vacuum and (load\$3 with (transport\$34 transfer\$4 convey\$4 mov\$4))	US-PGPUB; USPAT	OR	ON	2005/02/04 17:34
L10	58	9 not 1	US-PGPUB; USPAT	OR	ON	2005/02/04 17:34
S7	1	10/664,642	US-PGPUB; USPAT	OR	ON	2005/02/03 16:00
S8	3	tilt\$3 with boat with (evaporat\$4 vapor\$4)	EPO; JPO; DERWENT	OR	ON	2005/02/03 16:02
S9	6	(tilt\$3 with boat) same (evaporat\$4 vapor\$4)	EPO; JPO; DERWENT	OR	ON	2005/02/03 16:03
S10	/0	118/726.ccls. and (karla with moore)	EPO; JPO; DERWENT	OR	ON	2005/02/03 16:30
S11	0	118/726.ccls. and (karla )	EPO; JPO; DERWENT	OR	ON	2005/02/03 16:03

S12	6	118/726.ccls. and (karla )	US-PGPUB; USPAT	OR	ON	2005/02/03 17:09
S13	37	("20010011524"   "2665224"   "3029777"   "3266661"   "3458347"   "3515852"   "3721800"   "4023523"   "4197814"   "4254326"   "4264803"   "4332838"   "4401052"   "4426569"   "4436565"   "4627989"   "5182567"   "5253266"   "5268033"   "5302208"   "5433791"   "5510151"   "5531183"   "5596673"   "5679410"   "5709753"   "5803976"   "5906857"   "5944903"   "6179923"   "6189806"   "6202591").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/02/03 16:04
S14	4	("4023523").URPN.	USPAT	OR	ON	2005/02/03 16:20
S15	13	((("20030221620") or ("20040031442") or ("6246387") or ("20010024185") or ("20020001888") or ("20020011205") or ("20020030443") or ("20020067400") or ("20020076847") or ("6429100") or ("6496171") or ("20030015140") or ("6660332")).PN.	US-PGPUB; USPAT	OR	OFF	2005/02/03 16:22
S16	1186	118/726.ccls.	US-PGPUB; USPAT	OR	ON	2005/02/04 11:22
S17	4	S16 and (pre\$1heat\$3 with separate)	US-PGPUB; USPAT	OR	ON	2005/02/03 17:04
S18	8	S16 and (( initial\$3 pre\$1heat\$3) with separate)	US-PGPUB; USPAT	OR	ON	2005/02/03 16:35
S19	30	((crucible source trough holder) with (evaporat\$4 vapor\$7) with ( initial\$3 pre\$1heat\$3) with separate)	US-PGPUB; USPAT	OR	ON	2005/02/03 16:40
S20	4838	((crucible source trough holder) with (evaporat\$4 vapor\$7) with (transfer\$4 mov\$4 transport\$4 translat\$4))	US-PGPUB; USPAT	OR	ON	2005/02/03 16:41
S21	186	118/726.ccls. and ((crucible source trough holder) with (evaporat\$4 vapor\$7) with (transfer\$4 mov\$4 transport\$4 translat\$4))	US-PGPUB; USPAT	OR	ON	2005/02/03 17:22
S22	1	("5904961").PN.	US-PGPUB; USPAT	OR	OFF	2005/02/03 16:56
S23	8	09/843,489	US-PGPUB; USPAT	OR	ON	2005/02/03 16:56
S24	4	("4356429"   "4539507"   "4720432"   "4769292").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/02/03 17:03
S25	1	S16 and ((heat\$3) with (pre\$1heat\$3 begin\$3 start\$3 commenc\$4 initial\$4) with separate with chamber)	US-PGPUB; USPAT	OR	ON	2005/02/03 17:05
S26	10	(crucible source trough) with (vapor\$7 vapor\$7) with (heat\$3) with (pre\$1heat\$3 begin\$3 start\$3 commenc\$4 initial\$4) with separate with chamber	US-PGPUB; USPAT	OR	ON	2005/02/03 17:07
S27	1	(crucible source trough) with (vapor\$7 vapor\$7) with (heat\$3) with (pre\$1heat\$3 begin\$3 start\$3 commenc\$4 initial\$4) with separate with chamber	EPO; JPO; DERWENT	OR	ON	2005/02/03 17:08
S28	32	"118"/\$.ccls. and (karla ) and liquid	US-PGPUB; USPAT	OR	ON	2005/02/03 17:10
S29	72	"118"/\$.ccls. and (karla ) and moore	US-PGPUB; USPAT	OR	ON	2005/02/03 17:11
S30	22	("4550681"   "4564280"   "4900593"   "4922851"   "5020200"   "5252137"   "5612725"   "5654040"   "5769946"   "5788773"   "5854953"   "5885661"   "5942037"   "5954877"   "6120834"   "6139639"   "6248175"   "6364547"   "6387455"   "6423144"   "6514570"   "6824043").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/02/03 17:12
S31	245	118/726.ccls. and ((crucible source trough holder evaporater evaporator vaporiser vaporizer) with (evaporat\$4 vapor\$7) with (transfer\$4 mov\$4 transport\$4 translat\$4))	US-PGPUB; USPAT	OR	ON	2005/02/04 11:20
S32	941	S16 not S31	US-PGPUB; USPAT	OR	ON	2005/02/03 18:03
S33	32	("4542712").URPN.	USPAT	OR	ON	2005/02/03 18:34
S34	6	("4897290").URPN.	USPAT	OR	ON	2005/02/04 10:16

S35	1	("5186975").URPN.	USPAT	OR	ON	2005/02/04 10:42
S36	3	("4406252"   "4620081"   "4868003").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/02/04 11:07
S37	3	("6340501").URPN.	USPAT	OR	ON	2005/02/04 11:11
S38	8	("3552352"   "4592306"   "4803947"   "5293373"   "5512320"   "5525379"   "5616208"   "5770293").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/02/04 11:12
S39	439	((crucible source trough holder evaporater evaporator vaporiser vaporizer) with (evaporat\$4 vapor\$7) with (load\$3) with chamber)	US-PGPUB; USPAT	OR	ON	2005/02/04 11:21
S40	183	((crucible source trough holder evaporater evaporator vaporiser vaporizer) with (evaporat\$4 vapor\$7) with (load\$3) with chamber)	EPO; JPO; DERWENT	OR	ON	2005/02/04 12:27
S41	1186	118/726.ccls.	US-PGPUB; USPAT	OR	ON	2005/02/04 11:22
S42	0	S40 not S41	US-PGPUB; USPAT	OR	ON	2005/02/04 11:24
S43	1186	S41 not S40	US-PGPUB; USPAT	OR	ON	2005/02/04 11:25
S44	424	S39 not S41	US-PGPUB; USPAT	OR	ON	2005/02/04 11:46
S45	88	S41 and 204/298.\$ccls.	US-PGPUB; USPAT	OR	ON	2005/02/04 11:26
S46	2455	((118/719) or (414/939) or (156/345.31) or (156/345.32) or (204/298.25) or (204/298.35)).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/02/04 11:27
S47	121	S46 and 118/726.ccls.	US-PGPUB; USPAT	OR	ON	2005/02/04 11:27
S48	0	118/726.ccls. and "installation chamber"	USPAT	OR	ON	2005/02/04 13:35
S49	2	118/726.ccls. and "installation chamber"	US-PGPUB; USPAT	OR	ON	2005/02/04 11:47
S50	5	semiconductor.as. and "installation chamber"	US-PGPUB; USPAT	OR	ON	2005/02/04 11:49
S51	2	118/726.ccls. and "installation chamber"	US-PGPUB; USPAT	OR	ON	2005/02/04 11:49
S52	31	evaporat\$7 and "installation chamber"	US-PGPUB; USPAT	OR	ON	2005/02/04 12:05
S53	250	204/298.23.ccls.	US-PGPUB; USPAT	OR	ON	2005/02/04 12:05
S54	6	("4543275"   "4607152"   "4769292"   "5185181"   "5505985"   "5677546").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/02/04 12:21
S55	0	("6696096").URPN.	USPAT	OR	ON	2005/02/04 12:22
S56	42	((crucible source trough holder evaporater evaporator vaporiser vaporizer) with (evaporat\$4 vapor\$7) with (load\$3) with chamber) and (substrate wafer semiconductor)	EPO; JPO; DERWENT	OR	ON	2005/02/04 12:27
S57	42	((crucible source trough holder evaporater evaporator vaporiser vaporizer) with (evaporat\$4 vapor\$7) with (load\$3) with chamber) and (workpiece substrate wafer semiconductor)	EPO; JPO; DERWENT	OR	ON	2005/02/04 12:28
S58	159	118/726.ccls. and ((previous\$4 with heat\$3) pre\$1heat\$3)	US-PGPUB; USPAT	OR	ON	2005/02/04 13:41
S59	49	118/726.ccls. and (((previous\$4 with heat\$3) pre\$1heat\$3) with (crucible source trough holder evaporater evaporator vaporiser vaporizer))	US-PGPUB; USPAT	OR	ON	2005/02/04 13:46
S60	2	118/726.ccls. and (((previous\$4 with heat\$3) pre\$1heat\$3) with (crucible source trough holder evaporater evaporator vaporiser vaporizer) with (before prior first) with introduc\$4)	US-PGPUB; USPAT	OR	ON	2005/02/04 13:48

S61	20	118/726.cds. and ((previous\$4 before prior first pre\$3heat) with heat\$3 with (crucible source trough holder evaporater evaporator vaporiser vaporizer) with (before prior first) with introduc\$4)	US-PGPUB; USPAT	OR	ON	2005/02/04 13:50
S62	1460	((previous\$4 before prior first pre\$3heat) with heat\$3 with (crucible source trough holder evaporater evaporator vaporiser vaporizer) with (before prior first) with introduc\$4)	US-PGPUB; USPAT	OR	ON	2005/02/04 13:48
S63	444	((previous\$4 before prior first pre\$3heat) with heat\$3 with (crucible source trough holder evaporater evaporator vaporiser vaporizer) with (before prior first) with introduc\$4)	EPO; JPO; DERWENT	OR	ON	2005/02/04 13:48
S64	0	118/726.cds. and (pre\$3heat with (crucible source trough holder evaporater evaporator vaporiser vaporizer) with (before prior first) with introduc\$4)	US-PGPUB; USPAT	OR	ON	2005/02/04 13:50
S65	3	118/726.cds. and (pre\$3heat with (crucible source trough holder evaporater evaporator vaporiser vaporizer) )	US-PGPUB; USPAT	OR	ON	2005/02/04 13:52
S66	0	118/726.cds. and (mask with align\$4 with camera)	US-PGPUB; USPAT	OR	ON	2005/02/04 13:53
S67	4	(118/715-733.cds 156/345.\$ccls. 204/298.\$ccls.) and (mask with align\$4 with camera)	US-PGPUB; USPAT	OR	ON	2005/02/04 13:56
S68	190	(substrate wafer workpiece semiconductor) and (mask with align\$4 with camera)	US-PGPUB; USPAT	OR	ON	2005/02/04 13:56
S69	0	(c23c016\$.ipc.) and (mask with align\$4 with camera)	EPO; JPO; DERWENT	OR	ON	2005/02/04 13:56
S70	82	(substrate wafer workpiece semiconductor) and (mask with align\$4 with camera with "CCD")	US-PGPUB; USPAT	OR	ON	2005/02/04 13:57